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F49620-01-1-0398

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Execution Date(s) 22 March 2010

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4. Application or patent number(s):

A Patent Application No (s)
12/135,464

☐ This document is being filed together with a new application
B Patent No (s)

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Invention Title: Focused Negative Ion Beam Field SourceInventor(s): Martinez-Sanchez, ManuelLozano, Paulo C.U S. Filing/Issue Date: 06/09/2008Patent or Application Serial No.: 12/135464Grant/Contract Number(s): F49620-01-1-0398

Foreign Applications filed/Intended in (countries): _____

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